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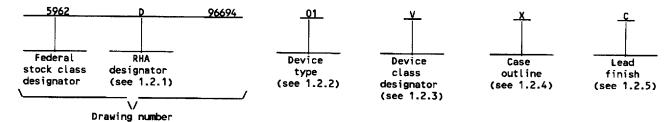
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1. SCOPE

- 1.1 <u>Scope</u>. This drawing forms a part of a one part one part number documentation system (see 6.6 herein). Two product assurance classes consisting of military high reliability (device classes Q and M) and space application (device class V), and a choice of case outlines and lead finishes are available and are reflected in the Part or Identifying Number (PIN). Device class M microcircuits represent non-JAN class B microcircuits in accordance with 1.2.1 of MIL-STD-883, "Provisions for the use of MIL-STD-883 in conjunction with compliant non-JAN devices." When available, a choice of Radiation Hardness Assurance (RHA) levels are reflected in the PIN.
 - 1.2 PIN. The PIN shall be as shown in the following example:



- 1.2.1 <u>RHA designator</u>. Device class M RHA marked devices shall meet the MIL-PRF-38535 appendix A specified RHA levels and shall be marked with the appropriate RHA designator. Device classes Q and V RHA marked devices shall meet the MIL-PRF-38535 specified RHA levels and shall be marked with the appropriate RHA designator. A dash (-) indicates a non-RHA device.
 - 1.2.2 <u>Device types</u>. The device types shall identify the circuit function as follows:

Device type	Generic number 1/	Circuit function	Access time
01	5104	4K X 1 Radiation hardened CMOS/SOS SRAM	250 ns

1.2.3 <u>Device class designator</u>. The device class designator shall be a single letter identifying the product assurance level as follows:

Device class

Device requirements documentation

М

Vendor self-certification to the requirements for non-JAN class B microcircuits in accordance with 1.2.1 of MIL-STD-883

Q or V

Certification and qualification to MIL-PRF-38535

1.2.4 <u>Case outline(s)</u>. The case outline(s) shall be as designated in MIL-STD-1835 and as follows:

Outline letter	Descriptive designator	<u>Terminals</u>	<u>Package style</u>
v	CDIP2-T18	18	Dual-in-line package
x	CDFP4-F24	24	Flat pack

1.2.5 <u>Lead finish</u>. The lead finish shall be as specified in MIL-STD-883 (see 3.1 herein) for class M or MIL-PRF-38535 for classes Q and V. Finish letter "X" shall not be marked on the microcircuit or its packaging. The "X" designation is for use in specifications when lead finishes A, B, and C are considered acceptable and interchangeable without preference.

1/ Generic numbers are listed on the Standard Microcircuit Drawing Source Approval Bulletin at the end of this document and will also be listed in QML-38535 and MIL-BUL-103.

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1.3 Absolute maximum ratings. 2/			
Supply voltage range	0.5 V dc to	0 V dc V _{DD} + 0.5 V dc	
Case V	. 0.64 W 3/		
Case X	. 0.63 W <u>3</u> /		
Lead temperature (soldering, 10 seconds maximum)	. +265°C		
Thermal resistance, junction-to-case (0 _{JC}): Case V	18°€/⊌		
Case X			
Thermal resistance, junction-to-ambient (8,14):			
Case V			•
Case X			
Junction temperature (T _j)		°C	
1.4 Recommended operating conditions.			
Supply voltage (V _{DD})	. +4.5 V dc to	+5.5 V dc	
Ground voltage (GŇĎ)	. 0.0 V dc		
Input high voltage (V _{IH})	. $V_{DD}/2$ to V_{DD}		
Input Low voltage (V _{IL})	. 0.0 V dc to +	0.8 V dc maximum	
Case operating temperature range (T _C)	55 6 10 +125	·	
Total dose irradiation	. ≥ 10 KRads(Si)	
Dose rate upset (20 ns pulse)	. ≥ 1 x 10 ¹⁰ Ra	ds(Si)/sec 4/	
	. ≥ 1 x 10 12 Ra	ds(Si)/sec 4/	
Single event phenomenon (SEP) effective linear energy threshold (LET) with no upsets	> 100 MeV//cm	2 _{/ma}) 4/	
	- Too nety tem	7.1197 ±2	
2. APPLICABLE DOCUMENTS			
2.1 <u>Government specification, standards, bulletin, and handbook of the issof Specifications and Standards specified in the solicitations.</u>	ue listed in tha	t issue of the Department	of Defense Index
SPECIFICATION			
MICROCIRCUIT			
MIL-PRF-38535 - Integrated Circuits, Manufacturing	, General Specif	ication for.	
STANDARDS	•		
MICROCIRCUIT			
MIL-STD-883 - Test Methods and Procedures for Micr MIL-STD-973 - Configuration Management. MIL-STD-1835 - Microcircuit Case Outlines.	oelectronics.		
BULLETIN			
MICROCIRCUIT			
MIL-BUL-103 - List of Standard Microcircuit Drawin	gs (SMD's).		
2/ Stresses above the absolute maximum rating may cause pe maximum levels may degrade performance and affect relia 3/ If device power exceeds package dissipation capability, based on Θ_{JA}) at the following rate: case outline V - 4/ Guaranteed by process or design, but not tested.	bility. provide heat si	nking or derate linearly	(the derating is
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HANDBOOK

MICROCIRCUIT

MIL-HDBK-780 - Standardized Military Drawings.

(Copies of the specification, standards, bulletin, and handbook required by manufacturers in connection with specific acquisition functions should be obtained from the contracting activity or as directed by the contracting activity.)

2.2 <u>Order of precedence</u>. In the event of a conflict between the text of this drawing and the references cited herein, the text of this drawing shall take precedence.

3. REQUIREMENTS

- 3.1 <u>Item requirements</u>. The individual item requirements for device class M shall be in accordance with 1.2.1 of MIL-STD-883, "Provisions for the use of MIL-STD-883 in conjunction with compliant non-JAN devices" and as specified herein. The individual item requirements for device classes Q and V shall be in accordance with MIL-PRF-38535, and as specified herein or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not effect the form, fit, or function as described herein.
- 3.2 <u>Design, construction, and physical dimensions</u>. The design, construction, and physical dimensions shall be as specified in MIL-STD-883 (see 3.1 herein) for device class M and MIL-PRF-38535 for device classes Q and V and herein.
 - 3.2.1 Case outlines. The case outlines shall be in accordance with 1.2.4 herein.
 - 3.2.2 <u>Terminal connections</u>. The terminal connections shall be as specified on figure 1.
 - 3.2.3 <u>Iruth table</u>. The truth table shall be as specified on figure 2.
 - 3.2.4 Irradiation test connections. The irradiation test connections shall be as specified in table III.
- 3.2.5 <u>Functional tests</u>. Functional tests used to test this device shall be maintained under document revision level control by the manufacturer and shall be made available to the preparing or acquiring activity upon request. For device classes Q and V, test patterns shall be under the control of the device manufacturer's Technology Review Board (TRB) in accordance with MIL-PRF-38535 and shall be made available to the preparing or acquiring activity upon request.
- 3.3 <u>Electrical performance characteristics and postirradiation parameter limits</u>. Unless otherwise specified herein, the electrical performance characteristics, and postirradiation parameter limits are as specified in table I and shall apply over the full case operating temperature range.
- 3.4 <u>Electrical test requirements</u>. The electrical test requirements shall be the subgroups specified in table IIA. The electrical tests for each subgroup are defined in table I.
- 3.5 <u>Marking</u>. The part shall be marked with the PIN listed in 1.2 herein. Marking for device class M shall be in accordance with MIL-SID-883 (see 3.1 herein). In addition, the manufacturer's PIN may also be marked as listed in MIL-BUL-103. Marking for device classes Q and V shall be in accordance with MIL-PRF-38535.
- 3.5.1 <u>Certification/compliance mark</u>. The compliance mark for device class M shall be a "C" as required in MIL-STD-883 (see 3.1 herein). The certification mark for device classes Q and V shall be a "QML" or "Q" as required in MIL-PRF-38535.
- 3.6 <u>Certificate of compliance</u>. For device class M, a certificate of compliance shall be required from a manufacturer in order to be listed as an approved source of supply in MIL-BUL-103 (see 6.7.2 herein). For device classes Q and V, a certificate of compliance shall be required from a QML-38535 listed manufacturer in order to supply to the requirements of this drawing (see 6.7.1 herein). The certificate of compliance submitted to DESC-EC prior to listing as an approved source of supply for this drawing shall affirm that the manufacturer's product meets, for device class M the requirements of MIL-STD-883 (see 3.1 herein), or for device classes Q and V, the requirements of MIL-PRF-38535 and the requirements herein.
- 3.7 <u>Certificate of conformance</u>. A certificate of conformance as required for device class M in MIL-STD-883 (see 3.1 herein) or for device classes Q and V in MIL-PRF-38535 shall be provided with each lot of microcircuits delivered to this drawing.
- 3.8 <u>Notification of change for device class M</u>. For device class M, notification to DESC-EC of change of product (see 6.2 herein) involving devices acquired to this drawing is required for any change as defined in MIL-STD-973.

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Test	Symbol	Conditions		Group A	Device	Lin	its	Unit
****		-55°C ≤ T _C ≤ +125°C unless otherwise specific	ed	subgroups	type	Min	Max	
High level input	v _{IH}	v _{DD} = 4.75 v		1,2,3	01	V _{DD} /2		v
vorrage			M,D	1 2/	_	3/		v
Low level input voltage	v _{IL}	V _{DD} = 4.75 V	— · !	1,2,3	01		0.8	v
vottage			M,D	1 2/	_		3/	٧
Output low drive current (sink)	IOL	V _{DD} = 4.75 V _{OUT} = 0.4 V		1.3	_ 01	4		mA
current (Sink)		VOUT = 0.4 V	14.0	2	_	2.5		
			M,D	1 2/		2.5		mA
Output high drive current (source)	ГОН	V _{DD} = 4.75 V _{OUT} = V _{DD} - 0.4 V		1.3	_ 01	-3		mA
current (source)		OUT TOD 5.4 4	M,D	2	_	-2		
			M, D	2/		-2		mA
Input leakage current	IIN	V _{DD} = 5.25 V, V _{IN} = GND or V _{DD}		1.3	_ 01	-2	2	μА
		VIN GIVE C. VDD	M,D	2	-	-10	10	
			,5	2/		-10	10	μΑ
High impedance output leakage	I _{OZ}	V _{DD} = 5.25 V, V _{I/O} = GND or V _{DD}		1.3	01	-5	5	μΑ
current		1/0 - and of vDD	M,D	2	-	-30	30	<u> </u>
				2/		-30	30	μA
Quiescent supply	IDD	V _{DD} = 5.25 V, V _{IN} = GND or V _{DD}		1.3	_ 01		0.1	mA
2=1.000		oly and a opp	M,D	2	_		1.0	
				2/			1.0	mA
Operating supply current	IOPER	V _{DD} = 5.25 V, f= 1 Mhz, V _{IN} = GND or V _{DD} , C _L = 50 pF		1,2,3	01		4.5	mA
.		CLN = 50 pF	M,D	1 2/			3/	mA
Operating supply	IOPRD	V _{DD} = 5.25 V, I _{OUT} = 0 mA, V _{IN} = GND or V _{DD} , f = 1 MH		1.3	01		0.1	mA
current (deselected)		VIN = GND or VDD, f = 1 MH		2	_	-	1	
			M,D,	2/			1	mA.
See footnotes at end of	table.			•		•		•
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Test	Symbol	Conditions		Group A	Device	<u></u>	imits	Unit
		-55°C ≤ T _C ≤ +125°C unless otherwise specifie	<u>.d</u>	subgroups	type	Min	Max	<u> </u>
Minimum data retention voltage	V _{DR}			1.3	_ 01		2.0	_ v
			M,D	2 1 2/			2.5	V
Data retention current	IDDDR	V _{DD} = V _{DR} , I _{DUT} = 0 mA V _{IN} = GWD or V _{DD}		1.3	_ 01		40	μΑ
		AIN = GMD OL ADD	1.5	2	_		400	
			M,D	1 2/			400	μА
Input capacitance 1/	CIN	V _{DD} = open, f = 1.0 MHz, see 4.4.1c		4	01		5	pF
Output capacitance 1/	Соит	V _{DD} = open, f = 1.0 MHz, see 4.4.1c		4	01		7	pF
Functional tests		See 4.4.1d, V _{DD} = 4.75 V f = 1 MHz, V ₁₁ = GND.		7,8A,8B	01	V _{OH} ≥ V _{DD/2}	V _{OL} ^s V _{DD} /2	
		V _{IH} = V _{DD}	M,D	7 2/		3/		
Read cycle	t _{AVAV}	See figure 4, V _{DD} = 4.75 V	4/	9.11	. 01	200		. ns
			T _M D	10		250	<u> </u>	<u> </u>
	<u> </u>	-	M,D	9 2/		250		ns
Address access time	t _{AVQV}		•-	9.11	. 01		200	ns
!			M,D	10			250	
	-			2/			250	ns
Chip enable access	tELQV			9.11	01		220	ns
			M,D	10			280	-
				2/			280	ns
Output hold from 1/ address	^t AVQZ			9.11	01		80	ns
Output hold from CE	t _{EHQZ}			9.11	01		100 80	ns
ν	Enwa			10	1		100	lis

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Test	Symbol	Conditions		Group A	Device	<u>Li</u>	mits	Unit
all the state of t		-55°C ≤ T _C ≤ +125°C unless otherwise specifie	d	subgroups	type	Min	Max	
Irite cycle	t _{AVAV}	See figure 4, $V_{DD} = 4.75 \text{ V}$	<u>4</u> /	9.11	01	200		_ ns
			M,D	10		250		<u> </u>
			F1,0	2/		250		ns
Irite pulse width <u>5</u> /	twLWH		·	9,11	01	125		_ ns
			14.5	10		145		
			M,D	9 2/		145		ns
Address set-up to	tavwL		1	9,10,11	01	0		ns
beginning of write			M,D	9 2/		3/		ns
Address set-up to end	tAVWH			9.11	01	160		_ ns
of write				10		205	ļ	
			M,D	9 2/		205		ns
Address hold time	t _{WHAV}			9.11	. 01	40		_ ns
			1	10		45		
			M,D	2/		45		ns
CE to write set-up	t _{ELWH}		1	9.11	. 01	160		_ ns
time				10	-	205		
			M,D	2/	:	205		ns
CE pulse width 5/	tELEH		1	9.11	01	180		_ ns
			-	10	_	220		
			M,D	9 2/		220		ns
Data to write set-up	^t DVwH			9.11	. 01	100		_ ns
time			100 -	10	-	120		-
			M,D	9 2/		120		ns

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-55°C ≤ T _C ≤ +125°C subgroups type 4.75 V ≤ V _{DD} ≤ 5.25 V unless otherwise specified Min		
	Max	
ata hold from write twhDX See figure 4, VDD = 4.75 V 4/ 9.11 01 5		_ ns
10 10 10		<u>.</u>

 $\underline{\mathcal{U}}$ Tested initially and after any design or process changes that affect that parameter, and therefore shall be guaranteed to the limits specified in table I.

y When performing postirradiation electrical measurements for any RHA level T_A = +25°C. Limits shown are guaranteed at T_A = +25°C ±5°C. The M and D in the test condition column are the postirradiation limits for the device types specified in the device types column.

3/ Preirradiation values for RHA marked devices shall also be the postirradiation values, unless otherwise specified.

4/ AC measurements assume rise and fall times of 5 ns or less, timing reference levels of V_{DD}/2 and C_L ≥ 50 pF.

5/ CE and WE must overlap for at least t_{WLWH} minimum value, t_{DVWH} minimum value must occur during this overlap.

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Device types	Al	.(
Case outlines	٧	х
Terminal number	Term s y m	inal bol
1	A _O	NC
2	A ₁	A _O
3	A ₂	A ₁
4	A ₃	A ₂
5	A4	A3
6	A ₅	NC
7	Dout	A ₄
8	₩E	A ₅
9	v _{ss}	D _{OUT}
10	CE	NC
11	DIN	WE
12	A ₁₁	v _{ss}
13	A ₁₀	CE
14	A ₉	NC
15	A ₈	DIN
16	A ₇	A ₁₁
17	A ₆	A ₁₀
18	v _{DD}	A ₉
19		NC
20		NC
21		A ₈
22		A7
23		A ₆
24		V _{DD}

FIGURE 1. <u>Ierminal connections</u>.

Mode	CE	WE	Outputs
Not selected	н	x	High Z
Write	L	L	High Z
Read	L	н	Data out

NOTES:

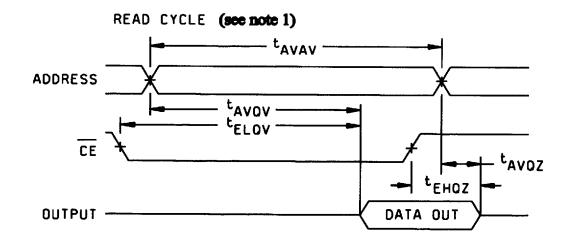
L = logic low voltage level; H = logic high voltage level; X can be H or L.
 High Z is high impedance state.

FIGURE 2. Iruth table.

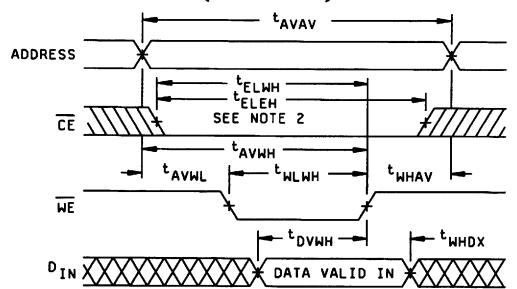
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WRITE CYCLE (see notes 1 and 2)



NOTES:

- <u>Ti</u>ming <u>me</u>asurement is referenced to V_{DD}/2.
 CE and WE must overlap for at least t_{WLWH} minimum value, t_{DVWH} minimum value must occur during this overlap.

FIGURE 3. Timing waveform.

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Table IIA. Electrical test requirements. 1/ 2/ 3/ 4/ 5/ 6/ 7/

	,	· · · · · · · · · · · · · · · · · · ·	;	
Line no.	Test requirements	Subgroups (per method 5005, table IA)	(per MIL-i	roups PRF-38535, : III)
		Device class M	Device class Q	Device class V
1	Interim electrical parameters (see 4.2)	1,7,9	1,7,9	1,7,9
2	Static burn-in I <u>8</u> / method 1015	Not required	Required	Required
3	Same as line 1		1*,7*,9	1*,7*,9 ∆*
4	Static burn-in II method 1015	Not required	Not required	Required
5	Same as line 1		1*,7*,9	1*,7*,9 Δ *
6	Dynamic burn-in (method 1015)	Required	Not required	Required
7	Final electrical parameters	1*,2,3,7*, 8A,8B,9,10, 11	1*,2,3,7*, 8A,8B,9,10, 11	1*,2,3,7*, 8A,8B,9,10, 11
8	Group A test requirements	1,2,3,4**,7,8 A,8B,9,10, 11	1,2,3,4**,7, 8A,8B,9,10, 11	1,2,3,4**,7, 8A,8B,9,10, 11
9	Group C end-point electrical parameters	1,2,3,7, 8A,8B	1,2,3,7, 8A,88,9,10, 11	1,2,3,7, 8A,8B,9,10, 11
10	Group D end-point electrical parameters	1,7,9	1,7,9	1,7,9
11	Group E end-point electrical parameters	1,7,9		1,7,9

- 1/ Blank spaces indicate test are not applicable.
- 2/ Any or all subgroups may be combined when using high-speed testers.
- 3/ Subgroups 7 and 8 functional tests shall verify the truth table.
- 4/ * Indicates subgroups used for PDA calculation.
- 5/ ** See 4.4.1c.
- 7/ See 4.5.
- 8/ 24 hours for class Q, 160 hours or equivalent for class V.

Table IIB. Delta limits at +25°C.

Test 1/	All device types
I _{OZ}	+500 nA of specified value in table I
IDD	+30 µA of specified value in table I
IOL	-15% of specified yalue in table I
но ^I	-15% of specified yalue in table I

1/ The above parameter shall be recorded before and after the required burn-in and life tests to determine the delta.

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TABLE II	TABLE III. Irradiation test connections. 1/2/			
Case	Ground	V _{DD} = 5 V ± 0.25 V		
V	9	1,2,3,4,5,6,7,8,10,11, 12,13,14,15,16,17,18		

- 1/ Each pin except V_{DD} , GND, and open connections will have a series resistor of $47k\Omega\pm5\%$, for irradiation testing.
- 2/ Irradiation samples only assembled in case outline V.
- 3.9 <u>Verification and review for device class M</u>. For device class M, DESC, DESC's agent, and the acquiring activity retain the option to review the manufacturer's facility and applicable required documentation. Offshore documentation shall be made available onshore at the option of the reviewer.
- 3.10 <u>Microcircuit group assignment for device class M</u>. Device class M devices covered by this drawing shall be in microcircuit group number 41 (see MIL-PRF-38535, appendix A).
 - 4. QUALITY ASSURANCE PROVISIONS
- 4.1 <u>Sampling and inspection</u>. For device class M, sampling and inspection procedures shall be in accordance with MIL-STD-883 (see 3.1 herein). For device classes Q and V, sampling and inspection procedures shall be in accordance with MIL-PRF-38535, or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not effect the form, fit, or function as described herein.
- 4.2 <u>Screening</u>. For device class M, screening shall be in accordance with method 5004 of MIL-STD-883, and shall be conducted on all devices prior to quality conformance inspection. For device classes Q and V, screening shall be in accordance with MIL-PRF-38535, and shall be conducted on all devices prior to qualification and technology conformance inspection.
 - 4.2.1 Additional criteria for device class M.
 - a. Delete the sequence specified as initial (preburn-in) electrical parameters through interim (postburn-in) electrical parameters of method 5004 and substitute lines 1 through 6 of table IIA herein.
 - b. For device class M, the test circuit shall be maintained by the manufacturer under document revision level control and shall be made available to the preparing or acquiring activity upon request. For device class M, the test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1015.
 - (1) Dynamic burn-in for device class M (method 1015 of MIL-STD-883, test condition D; for circuit, see 4.2.1b herein).
 - c. Interim and final electrical parameters shall be as specified in table IIA herein.
 - 4.2.2 Additional criteria for device classes Q and V.
 - a. The burn-in test duration, test condition, and test temperature or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The burn-in test circuit shall be maintained under document revision level control of the device manufacturer's Technology Review Board (TRB) in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1015 or as modified in the device manufacturer's QM plan.
 - b. Interim and final electrical test parameters shall be as specified in table IIA herein.
 - c. Additional screening for device class V beyond the requirements of device class Q shall be as specified in appendix B of MIL-PRF-38535 or as modified in the device manufacturers Quality Management (QM) plan.
- 4.3 <u>Qualification inspection for device classes Q and V</u>. Qualification inspection for device classes Q and V shall be in accordance with MIL-PRF-38535. Inspections to be performed shall be those specified in MIL-PRF-38535 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.4).
- 4.4 <u>Conformance inspection</u>. Quality conformance inspection for device class M shall be in accordance with MIL-STD-883 (see 3.1 herein) and as specified herein. Inspections to be performed for device class M shall be those specified in method 5005 of MIL-STD-883 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.4). Technology conformance inspection for classes Q and V shall be in accordance with MIL-PRF-38535 or as specified in the QN plan, including groups A, B, C, D, and E inspections and as specified herein except where option 2 of MIL-PRF-38535 permits alternate in-line control testing.

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- 4.4.1 Group A inspection.
 - a. Tests shall be as specified in table IIA herein.
 - b. Subgroups 5 and 6 in table I, method 5005 of MIL-STD-883 shall be omitted.
 - c. For device class M, subgroups 7 and 8 tests shall be sufficient to verify the truth table. For device classes Q and V, subgroups 7 and 8 shall include verifying the functionality of the device.
 - d. Subgroup 4 ($C_{\rm IN}$ and $C_{\rm OUT}$ measurements) shall be measured only for initial qualification and after any process or design changes which may affect input or output capacitance. Capacitance shall be measured between the designated terminal and GND at a frequency of 1 MHz. Sample size is 5 devices with no failures, and all input and output terminals tested.
- 4.4.2 <u>Group C inspection</u>. The group C inspection end-point electrical parameters shall be as specified in table IIA herein.
 - 4.4.2.1 Additional criteria for device class M. Steady-state life test conditions, method 1005 of MIL-STD-883:
 - a. Test condition A, B, C, or D. The test circuit shall be maintained by the manufacturer under document revision level control and shall be made available to the preparing or acquiring activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005.
 - b. $T_A = +125$ °C, minimum.
 - c. Test duration: 1,000 hours, except as permitted by method 1005 of MIL-STD-883.
- 4.4.2.2 <u>Additional criteria for device classes Q and V</u>. The steady-state life test duration, test condition, and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The test circuit shall be maintained under document revision level control by the device manufacturer's TRB in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005.
- 4.4.3 <u>Group D inspection</u>. For group D inspection, end-point electrical parameters shall be as specified in table IIA herein.
- 4.4.4 <u>Group E inspection</u>. Group E inspection is required only for parts intended to be marked as radiation hardness assured (see 3.5 herein). RHA levels for device classes M, Q and V shall be as specified in MIL-PRF-38535. End-point electrical parameters shall be as specified in table IIA herein.
- 4.4.4.1 <u>Total dose irradiation testing</u>. Total dose irradiation testing shall be performed in accordance with MIL-STD-883 method 1019 and as specified herein.
- 4.4.4.1.1 <u>Accelerated aging test</u>. Accelerated aging tests shall be performed on all devices requiring a RHA level greater than 5k rads(Si). The post-anneal end-point electrical parameter limits shall be as specified in table I herein and shall be the pre-irradiation end-point electrical parameter limit at 25°C ±5°C. Testing shall be performed at initial qualification and after any design or process changes which may affect the RHA response of the device.
- 4.4.4.2 <u>Dose rate induced latchup testing</u>. Dose rate induced latchup testing shall be performed in accordance with test method 1020 of MIL-STD-883 and as specified herein (see 1.4). Tests shall be performed on devices, SEC, or approved test structures at technology qualification and after any design or process changes which may effect the RHA capability of the process.
- 4.4.4.3 <u>Dose rate upset testing</u>. Dose rate upset testing shall be performed in accordance with test method 1021 of MIL-STD-883 and herein (see 1.4).
 - a. Transient dose rate upset testing shall be performed at initial qualification and after any design or process changes which may effect the RHA performance of the devices. Test 10 devices with 0 defects unless otherwise specified.
 - b. Transient dose rate upset testing for class Q and V devices shall be performed as specified by a TRB approved radiation hardness assurance plan and MIL-PRF-38535.

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- 4.4.4.4 <u>Single event phenomena (SEP)</u>. SEP testing shall be required on class V devices (see 1.4 herein). SEP testing shall be performed on a technology process on the Standard Evaluation Circuit (SEC) or alternate SEP test vehicle as approved by the qualifying activity at inital qualification and after any design or process changes which may affect the upset or latchup characteristics. The recommended test conditions for SEP are as follows:
 - a. The ion beam angle of incidence shall be between normal to the die surface and 60° to the normal, inclusive (i.e. 0° ≤ angle ≤ 60°). No shadowing of the ion beam due to fixturing or package related effects is allowed.
 - b. The fluence shall be ≥ 100 errors or $\ge 10^6$ ions/cm².
 - c. The flux shall be between 10^2 and 10^5 ions/cm²/s. The cross-section shall be verified to be flux independent by measuring the cross-section at two flux rates which differ by at least an order of magnitude.
 - d. The particle range shall be \geq 20 microns in silicon.
 - e. The test temperature shall be +25 °C and the maximum rated operating temperature ±10 °C.
 - f. Bias conditions shall be defined by the manufacturer for latchup measurements.
 - g. Test four devices with zero failures.
- 4.5 <u>Delta measurements for device class V</u>. Delta measurements, as specified in table IIA, shall be made and recorded before and after the required burn-in screens to determine delta compliance. The electrical parameters to be measured, with associated delta limits are listed in table IIB. The device manufacturer may, at his option, either perform delta measurements or within 24 hours after burn-in perform final electrical parameter tests, subgroups 1, 7, and 9.

PACKAGING

5.1 <u>Packaging requirements</u>. The requirements for packaging shall be in accordance with MIL-STD-883 (see 3.1 herein) for device class M and MIL-PRF-38535 for device classes Q and V.

6. NOTES

- 6.1 <u>Intended use</u>. Microcircuits conforming to this drawing are intended for use for government microcircuit applications (original equipment), design applications, and logistics purposes.
- 6.1.1 <u>Replaceability</u>. Microcircuits covered by this drawing will replace the same generic device covered by a contractor-prepared specification or drawing.
 - 6.1.2 <u>Substitutability</u>. Device class Q devices will replace device class M devices.
- 6.2 <u>Configuration control of SMD's</u>. All proposed changes to existing SMD's will be coordinated with the users of record for the individual documents. This coordination will be accomplished in accordance with MIL-STD-973 using DD Form 1693, Engineering Change Proposal (Short Form).
- 6.3 <u>Record of users</u>. Military and industrial users shall inform Defense Electronics Supply Center when a system application requires configuration control and which SMD's are applicable to that system. DESC will maintain a record of users and this list will be used for coordination and distribution of changes to the drawings. Users of drawings covering microelectronics devices (FSC 5962) should contact DESC-EC, telephone (513) 296-6047.
- 6.4 <u>Comments</u>. Comments on this drawing should be directed to DESC-EC, Dayton, Ohio 45444, or telephone (513) 296-5377.
 - 6.5 Symbols, definitions, and functional descriptions.

CIN Input terminal capacitance.

COUT Output terminal capacitance.

GND Ground zero voltage potential.

IDD Input current.

II Output current.

TC Case temperature.

VDD Positive supply voltage.

6.5.1 <u>Iiming limits</u>. The table of timing values shows either a minimum or a maximum limit for each parameter. Input requirements are specified from the external system point of view. For example, address setup time would be shown as a minimum since the system must supply at least that much time (even though most devices do not require it). On the other hand, responses from the memory are specified from the device point of view. For example, the access time would be shown as a maximum since the device never provides data later than that time,

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6.5.2 Waveforms.

Waveform symbol	Input	Output
	MUST BE VALID	WILL BE VALID
	CHANGE FROM H TO L	WILL CHANGE FROM H TO L
	CHANGE FROM L TO H	WILL CHANGE FROM L TO H
XXXXXX	DON'T CARE ANY CHANGE PERMITTED	CHANGING STATE UNKNOWN
		HIGH IMPEDANCE

6.6 One part - one part number system. The one part - one part number system described below has been developed to allow for transitions between identical generic devices covered by the three major microcircuit requirements documents (MIL-H-38534, MIL-PRF-38535, and 1.2.1 of MIL-STD-883) without the necessity for the generation of unique PIN's. The three military requirements documents represent different class levels, and previously when a device manufacturer upgraded military product from one class level to another, the benefits of the upgraded product were unavailable to the Original Equipment Manufacturer (OEM), that was contractually locked into the original unique PIN. By establishing a one part number system covering all three documents, the OEM can acquire to the highest class level available for a given generic device to meet system needs without modifying the original contract parts selection criteria.

Military documentation format	Example PIN under new system	Manufacturing source listing	Document <u>Listing</u>
New MIL-H-38534 Standard Microcircuit Drawings	5962-XXXXXZZ(H or K)YY	QML-38534	MIL-BUL-103
New MIL-PRF-38535 Standard Microcircuit Drawings	5962-XXXXXZZ(Q or V)YY	- QML-38535	M1L-BUL-103
New 1.2.1 of MIL-STD-883 Standard Microcircuit Drawings	5962-XXXXXZZ(M)YY	MIL-BUL-103	MIL-BUL-103

6.7 Sources of supply.

- 6.7.1 Sources of supply for device classes Q and V. Sources of supply for device classes Q and V are listed in QML-38535. The vendors listed in QML-38535 have submitted a certificate of compliance (see 3.6 herein) to DESC-EC and have agreed to this drawing.
- 6.7.2 <u>Approved sources of supply for device class M</u>. Approved sources of supply for class M are listed in MIL-BUL-103. The vendors listed in MIL-BUL-103 have agreed to this drawing and a certificate of compliance (see 3.6 herein) has been submitted to and accepted by DESC-EC.
- 6.8 <u>Additional information</u>. A copy of the following additional data shall be maintained and available from the device manufacturer:
 - a. RHA upset levels.
 - b. Test conditions (SEP).
 - c. Number of upsets (SEP).
 - d. Number of transients (SEP).
 - e. Occurence of latchup (SEP).

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